

DEC 21 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jaiswal
Serial No: 10/679,783
Filed: 10/6/2003
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT
USING RF PLASMA SPUTTER ETCH

Docket No: TI-34403.1
Examiner: McDonald, Rodney Glenn
Art Unit: 1753

AMENDMENT UNDER 37 C.F.R. § 1.116

Assistant Commissioner For Patents
Washington, DC 20231

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on 12-21-05.

Tommie Chambers
Tommie Chambers

Dear Sir:

Responsive to the Office Action mailed September 16, 2005 in connection with the above identified application, Applicants respectfully submit the following amendments and remarks.

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Entered
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11/13/06
W.M.
11/18/06

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